

# Search Notes



Application No.

10/626,440

Examiner

Alicia M Harrington

Applicant(s)

SHAVER, DAVID C.

Art Unit

2873

## SEARCHED

Class	Subclass	Date	Examiner
359	562,563	11/30/04	AM
355	57		
	71,77		
430	5		
	22		
	756		
359	738	12/1/04	AM
	739		
	740		

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
consulted John Juba (primary in 359) for search	11/29/04	AM
Letters on polarization + exposure process	12/6/04	AM
consulted Nguyen Hung (primary 2851) for search	11/29/04	AM
consulted Mark Chapman in class 430 for search	11/29/04	AM
Ext Text Search	11/30/04	AM
	12/11/04	AM